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Bio Data Sheet

CONFIRMATION NO. 2644

SERIAL NUMBER 10/735,621	FILING DATE 12/16/2003 ✓ RULE	CLASS 118	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 829-619
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** CONTINUING DATA *****

NONE MTC

** FOREIGN APPLICATIONS *****

JAPAN 2002-367402 12/18/2002

MTC

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/24/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 10	TOTAL CLAIMS 26	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	Met after Allowance <i>MTC</i>			

ADDRESS

23117
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TITLE

Plasma CVD apparatus, and method for forming film and method for forming semiconductor device using the same

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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